

## **COPY OF PAPERS ORIGINALLY FILED**

## <u>PATENT APPLICATION</u>

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Yogesh B. Gianchandani,

Chester G. Wilson

Date: January 22, 2002

Group Art Unit: 1765

Docket No.: 032026:0485

Serial No.:

09/686,259

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For:

METHOD AND APPARATUS FOR ETCHING AND DEPOSITION

**USING MICRO-PLASMAS** 

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, U.S. Patent and Trademark Office, Washington, D.C. 20231 on January

22, 2002.

Harry C. Engstrom

(Name of applicant, assignee or Registered Representative)

January 22, 2002

(Date of Signature)

## REQUEST FOR STATUS

Commissioner for Patents U.S. Patent and Trademark Office Washington, D.C. 20231

Dear Sir:

Applicants hereby requests that applicants' undersigned attorney be advised of the current status of the above-referenced application.

The last communication from the Patent and Trademark Office on this application was the Updated Filing Receipt received by applicants' attorney on April 13, 2001.

A duplicate of this Request for Status is enclosed for use by the Patent and Trademark Office to expedite notification of applicants' attorney as to the status of the application.

Respectfully submitted,

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